



Docket No.: M4065.0392/P392
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Paul A. Farrar, et al.

Application No.: 09/773,522

Art Unit: 1762

Filed: February 20, 2001

Examiner: B. Talbot

For: MICRO C-4 SEMICONDUCTOR DIE
AND METHOD FOR DEPOSITING
CONNECTION SITES THEREON

AMENDMENT

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This is in response to the Office Action dated September 4, 2003 (Paper No. 7), finally rejecting claims 34-45. Concurrently herewith, Applicants have petitioned for a one-month extension of time and a Request for Continued Examination. Consequently, this response is timely filed by January 4, 2004. Please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.